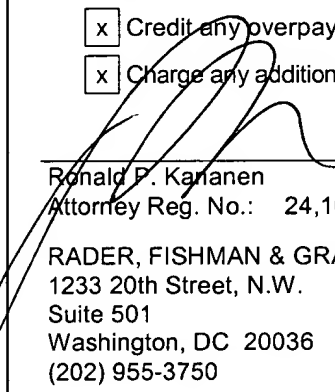


1F2815 \$

AMENDMENT TRANSMITTAL LETTER				Docket No. SON-1718	
Application No. 09/478,812-Conf. #2204		Filing Date January 7, 2000		Examiner E. Lee	
Art Unit 2815					
Applicant(s): Yasukiyasu Sugano et al.					
Invention: PROCESS FOR PRODUCING THIN FILM SEMICONDUCTOR DEVICE AND LASER IRRADIATION APPARATUS					
TO THE COMMISSIONER FOR PATENTS					
Transmitted herewith is an amendment in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	14	- 74 =		x	0.00
Independent Claims	14	- 31 =		x	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify): Extension for response within third month					1,020.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					1,020.00
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input type="checkbox"/> No additional fee is required for this amendment.					
<input checked="" type="checkbox"/> Please charge Deposit Account No. <u>18-0013</u> in the amount of \$ <u>1,020.00</u> . A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>18-0013</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 _____ Ronald P. Kananen Attorney Reg. No.: 24,104 RADER, FISHMAN & GRAUER PLLC 1233 20th Street, N.W. Suite 501 Washington, DC 20036 (202) 955-3750				Dated: <u>June 13, 2005</u>	
DC197352					



Docket No.: SON-1718
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yasukiyasu Sugano et al.

Confirmation No. 2204

Application No.: 09/478,812

Art Unit: 2815

Filed: January 7, 2000

Examiner: E. Lee

For: PROCESS FOR PRODUCING THIN FILM
SEMICONDUCTOR DEVICE AND LASER
IRRADIATION APPARATUS

AMENDMENT RESPONSIVE TO ACTION OF DECEMBER 13, 2005

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In full and timely response to the Action of December 13, 2004, please further amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 10 of this paper.